IN THE UNITED STATES PATENT AND TRADEMARK OFFICE BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES Group Art Unit: 1765 pplication of: Toshiaki ONO, et al. RECEIVED Examiner: ANDERSON, Matthew A. Serial No.: 09/883,922 DEC 16 2003 P.T.O. Confirmation No.: 3735 Filed: June 20, 2001 METHOD OF MANUFACTURING EF170 PIAL WAFER AND METHOD OF For: PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR Attorney Docket No.: 010789 Customer No.: 38834 NOTICE OF APPEAL

Commissioner for Patents
P.O. Box 1450

Sir:

Alexandria, Virginia 22313-1450

Date: December 11, 2003

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the decision dated September 11, 2003 of the Primary Examiner.

The item(s) checked below are appropriate:

. 1.	[] A petition for a extension of time to respond to the Final Rejection was filed on
2 .	[] A timely response to the Final Rejection has been filed, as provided in 37 C.F.R. 1.113.
3.	[X] Fee -\$330.00 or [] Small Entity -\$165.00
	[X] Enclosed[] Not required (fee paid in prior appeal)[] Charge to Deposit Account No. 50-2866

In the event this Notice of Appeal is not considered to be timely filed, Applicants hereby petition for an appropriate extension of time. The fee for this extension may be charged to our Deposit Account No. 50-2866, along with any other additional fees which may be required with respect to this Notice.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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